

04-09-01

A

Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b))

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11000 U.S. PRO
09/827463
04/06/01

Date: April 6, 2001

Attorney Docket No.: 450100-03126

ASSISTANT COMMISSIONER FOR PATENTS
Box Patent Application
Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Makoto TABUCHI, Ichiro FUJISAWA

entitled:

DATA RECORDING/REPRODUCTION APPARATUS AND DATA RECORDING/REPRODUCTION METHOD

The following are enclosed:

Specification (33 pages)
 4 Sheet(s) of Drawings
 4 Claim(s) (including 2 independent claim(s))
 This application contains a multiple dependent claim

 Our check for \$ 710.00, calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:

Basic Fee, \$710.00 (\$355.00) \$ 710.00
Number of Claims in excess of 20 at \$18.00 (\$9.00) each: -0-
Number of Independent Claims in excess of 3 at \$80.00 (\$40.00) each: . . -0-
Multiple Dependent Claim Fee at \$270.00 (\$135.00) -0-
Total Filing Fee \$ 710.00
 Assignment Recording Fee \$40.00 -0-

 Oath or Declaration and Power of Attorney
 New signed unsigned
 Copy from a prior application (37 C.F.R. 1.63(d))

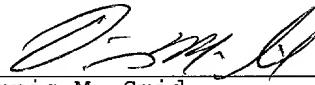
 Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

<u>Application No.</u>	<u>Filed</u>	<u>In</u>
2000-111945	7 April 2000	Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicants

By: 
Dennis M. Smid
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Assistant Commissioner for Patents
Washington, D.C. 20231

Re: U.S. Patent Application
Applicants: Makoto TABUCHI, Ichiro FUJISAWA
Our Ref.: 450100-03126

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

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Respectfully,



Dennis M. Smid
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Enclosures